

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Lange § §			Group Art Unit: 2878 Examiner: Unknown							
Serial No. 10/725,744			Atty. Dkt. No. 5589-05201							
Serial No. 10/725,744 § Filed: December 2, 2003 § For: SYSTEMS FOR INSPECTING SERIES AND RETICLES WITH SERIES INCREASED RESOLUTION § § § §			I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on the date indicated below: 426-04 Banela Benk							
		INFORMATION DISCLOS	URE STATEMENT							
	ant Commissio ngton, D.C. 20									
		nal information identified below in	paragraph 3. A copy of each reference listed on							
1.	This Information Disclosure Statement is submitted:									
	 a. □ within 3 months of the filing date of a national application other than a continued prosecution application under § 1.53(d); □ within 3 months of the date of entry of the national stage as set forth in § 1.491 in an International application; □ before the mailing date of a first Office Action on the merits; or before the mailing of a first Office Action after the filing of a request for continued examination under § 1.114. 									
	b.	after the events of above paragraph 1a and prior to the mailing date of a final Office Action or Notice of Allowance, and thus: the certification of paragraph 2 below is provided, or a fee of \$180.00 is enclosed.								
	c. 🗌	-	Office Action or a Notice of Allowance and prior thus: the certification of paragraph 2 below is enclosed.							

2.	It is he	It is hereby certified:				
		that each item of information contained in this Information Disclosure Statement cited in a communication from a foreign patent office in a counterpart foreign application more than three months prior to the filing of the Statement, or				
		that no item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in § 1.56 (c) more than three months prior to the filing of the Statement.				
3.		Consideration of the following additional information (including any co-pending or abandoned U.S. applications, prior uses and/or sales, etc.) is requested:				
4.	For each non-English language reference listed on the attached Form PTO-1449:					
		reference is made to an English language translation submitted herewith, and/or				
		reference is made to a foreign patent office search report (in the English language) submitted herewith, and/or				
		reference is made to an English language translation of a foreign patent office search report submitted herewith, and/or				
		reference is made to the concise explanation contained in the specification of the present application at page(s), and/or				
		reference is made to the concise explanation set forth below:				
5.		Applicant also offers the following comments for the Examiner's consideration:				
6.		Also enclosed is a copy of a foreign search report citing these references.				
7.		The listed documents were brought to the attention of the Applicant(s) after paymer the issue fee in the captioned case. The documents were cited in a communication from foreign patent office in a counterpart foreign application not more than three months provided to the filing of this Information Disclosure Statement. Applicant(s) request Information Disclosure Statement and attached Form PTO-1449 be placed in the filt the captioned application.				
8.		Applicant(s) requests that the Information Disclosure Statement and attached Form PTO-1449 and references, which are being filed before the grant of the patent and pursuant to 37 C.F.R. § 1.97(i), be placed in the file of the captioned application.				

If any required fees are missing, the Commissioner is authorized to charge said fees to Conley Rose, P.C. Deposit Account No. 03-2769/5589-05201.

Respectfully submitted,

Ann Marie Mewherter

Reg. No. 50,484

Agent for Applicant(s)

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Date: 4-26-04

Form PTO-1449 (modified)
List of Patents and Publications
Applicant's Information
Disclosure Statement

ATTY. DKT. NO. 5589-05201

SERIAL NO. 10/725,744

APPLICANT: Lange

GROUP: 2878

FILING DATE: December 2, 2003 (Use several sheets if necessary) **U.S. PATENT DOCUMENTS DOCUMENT NUMBER** FILING DATE IF EXAM. REF. DATE NAME CLASS **SUB** APPROPRIATE **INITIALS** DES. **CLASS** FOREIGN PATENT DOCUMENTS TRANSLATION DATE EXAM. REF. **DOCUMENT NUMBER** COUNTRY CLASS SUB YES/NO **INITIALS** DES **CLASS A1** 00/23840 4/27/00 WO **A2** 8/15/02 WO 02/063613 OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) Love et al., "Microscope Projection Photolithography for Rapid Prototyping of Masters with Micron-**A3** Scale Features for Use in Soft Lithography," Langmuir, Vol. 17, 2001, pp. 6005-6012. Genut et al., "Chemically Assisted Laser Removal of Photoresist and Particles from Semiconductor **A4** Wafers," presented at the 28th Annual Meeting of the Fine Particle Society, 1988, 11 pages.

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DATE CONSIDERED:

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the patent owner.